# Monthly LabAdviser update: 14/3 2016

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| Updated Subject  | Contributor | Link to the updated pages |
| **E-beam lithography on SEM**Raith on SEM added to E-beam lithography comparison tableE-beam lithography with Raith Elphy | **William Tiddi @danchip** | [EBeamLithography#Performance\_of\_the\_e-beam\_writers\_at\_DTU\_Danchip](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography#Performance_of_the_e-beam_writers_at_DTU_Danchip)[EBeamLithography/RaithElphy](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography/RaithElphy) |
| **E-beam lithography**Contrast curves of CSAR | **Tine Greibe** **@danchip** |  [Lithography/CSAR#Contrast\_Curves](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/CSAR#Contrast_Curves) |

# Equipment Manuals updated in LabManager:

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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|  | **Manual for Spin Coater: Gamma UV** |

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